

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Se-Jin CHUNG	)	
	)	
Application No.: Divisional of 09/965,844	)	Group Art Unit: 1765
	)	
Filed: October 21, 2003	)	Examiner: F. Hiteshew
	)	
For: EXCIMER LASER CRYSTALLIZATION	)	<b>Mail Stop Patent Application</b>
OF AMORPHOUS SILICON FILM	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, **Mail Stop Patent Application**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

**PRELIMINARY AMENDMENT**

Prior to the examination of the above-identified application on the merits, please amend  
the application as follows: